IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Wu et al

Serial No.

Herewith

Filed For

Examiner

Group

Radio Frequency Identification System



Information Disclosure Statement

Assistant Commissioner for Patents Washington, DC 20231

Sir:

Applicant desires to bring to the attention of the Office the following references that may be material to the examination of the above identified application.

Application submits this statement pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56 and MPEP 2001.1.

U.S. Patent Documents:

Patent No.	Patentee	Date
(150 540 D1	37 1	01 00 0001
6,170,742 B1	Yacoob	01-09-2001
6,195,006 B1	Bowers et al	02-27-2001
5,963,134	Bowers et al	10-05-1999
6,105,004	Halperin et al	08-15-2000
5,873,070	Bunte et al	02-16-1999
6,194,993 B1	Hayashi et al	02-27-2001
5,113,349	Nakamura et al	05-12-1992
5,841,122	Kirchoff	11-24-1998
5,929,414	Saitoh	07-27-1999

6,104,311	Lastinger	08-15-2000
5,151,684	Johnson	09-29-1992
5,892,441	Woolley et al	04-06-1999

The references are listed on the enclosed Form PTO/SB/08A and a copy of each reference is enclosed. Consideration of the references is requested.

Respectfully Submitted,

John Vanden Bosche Registration No. 35,396

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PTO/SB/08A (08-00)

Kung Chris Wu

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Substitute for form 1449A/PTO	Complete if Known					
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.						
	U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE					
	Approved for use through 10/31/2002, OMB 0651-0031					

Application Number

First Named Inventor Group Art Unit

Filing Date

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)	Examiner Name
of 1	Attorney Docket Number

				U.S. PATENT DOCI	UMENTS	
Examiner Initials*	Cite No.1	U.S. Patent Number	Kind Code ²	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		6,170,	742	Yacoob	01-09-2001	
		6,195,	006	Bowers et al	02-27-2001	
		5,963,		Bowers et al	10-05-1999	
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		5,892,	441	Woolley et al	04-06-1999	
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				FORE	IGN PATENT DOCUMENT	rs		
Examiner	Cite	Foreign Patent Document		Name of Patentee or	Date of Publication of	Pages, Columns, Lines, Where Relevant		
Initials*	No.1	Office ³	Number ⁴	Kind Code⁵ (if known)	Applicant of Cited Document	Cited Document MM-DD-YYYY	Passages or Relevant Figures Appear	T6
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Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the senal number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST, 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.